MAR 1 7 2010

S/N 10/565716

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

MURAKAMI, ET AL.

Examiner:

HA, NGUYEN T

Serial No.:

10/565716

Group Art Unit:

2831

Filed:

January 25, 2006

Docket No.:

20162.0012USWO

Title:

METHOD FOR FORMING OXIDE FILM ON METAL SURFACE USING

IONIC LIQUID, ELECTROLYTIC CAPACITOR AND ELECTROLYTE

THEREOF

CERTIFICATE UNDER 37 CFR 1.6(d):

I hereby certify that this paper is being transmitted by facsimile to the U.S. Patent and Trademark Office on March 17.

2010.

AMENDMENT AND RESPONSE

Mail Stop: AMENDMENT Commissioner for Patents

P.O. Box 1450

Alexandria, Virginia 22313-1450

Dear Commissioner:

In response to the Office Action mailed November 24, 2009, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims that begins on page 2 of this paper.

Remarks begin on page 5 of this paper.